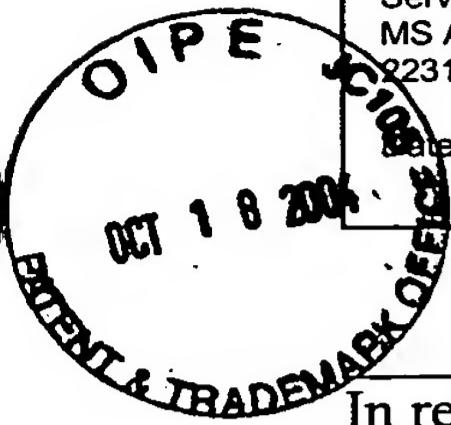
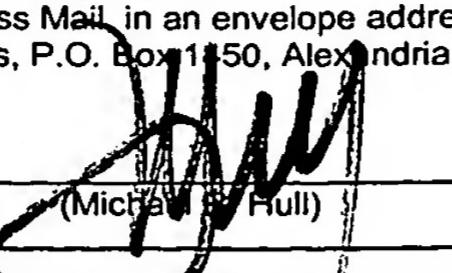


ZFW



I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to:
MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA
22313-1450, on the date shown below.

Dated: October 14, 2004 Signature: 
(Michael R. Hull)

Docket No.: 29936/39485
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kwan Y. Lim et al.

Application No.: 10/615,478

Art Unit: 2829

Filed: July 8, 2003

Examiner: Not Yet Assigned

For: **METHOD OF FORMING GATE IN
SEMICONDUCTOR DEVICE**

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated July 14, 2004, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 8 of this paper.

Remarks/Arguments in support of the allowability of this application begin on page 12 of this paper.